Docket No: 740756-2626

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re l	Divisional Patent Application of)
Shunp	pei YAMAZAKI et al.)
Based	On Application No. 09/493,411) Art Unit: 2815
Whic	h Was Filed: January 28, 2000) Examiner: G. Eckert II
For:	SEMICONDUCTOR DEVICE AND)
	METHOD OF FABRICATING THE)
	SAME) Date: June 26, 2003

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

The references listed on the attached Form PTO-1449 were cited in parent application Serial No. 09/493,411 filed January 28, 2000, from which priority is claimed under 35 U.S.C. 120.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

Jeffrey L. Gostellia

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NVA269045.1

Substitute for form 1449A/PTO				Complete if Known		
INFORMATION DISCLOSURE			OSURE	Application Number	New Divisional Application	
	STATEMENT BY APPLICANT		Filing Date	June 26, 2003		
SIA		First Named Inventor	Shunpei YAMAZAKI et al.			
	(use as many sheets as necessary)			Art Unit	2815	
		Examiner Name	G. Eckert, II			
Sheet	1	of	2	Attorney Docket Number	740756-2626	

			U.S. PATENT DOCUM	ENTS	
Examiner Initials	Cite No.1	U.S. Patent Document Number - Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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		US-5,739,549	04/1998	Takemura et al.	
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		FC	DREIGN PATENT D	OCUMENTS			
Examiner Initials	Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or	Pages, Columns, Lines, Where Relevant Passages or Relevant		
	ì	Country Code ³ Number ⁴ (if known)	MM-DD-YYYY	Application of Cited Document	Figures Appear	T⁵	
		GB 2-307 326	05/1997	Shin et al.		_	
						_	
		<u> </u>	<u> </u>				
		OTHER PRIOR	ART – NON PATENT L	ITERATURE DOCUMENTS			
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published.					
		Shimokawa et al., "Characterization of High-Efficiency Cast-Si Solar Cell Wafers by MBIC Measurement", Japanese Journal of Applied Physics, Vol. 27, No. 5, May, 1988, pp. 751-758.					
	 						

Examiner	Date
Signature	Considered

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

Sheet 2 of 2

Form PTO- (Rev. 8-83)	•	U.S. Department of Commerce Patent and Trademark Office		Attorney Docket: 740756-2626		Serial No.	
INI	FORMATION DISCLOSURE STATES	MENT					
	(Use several sheets if necessary)						
			Applicant: Shunpei	YAMAZAKI	et al.		
			Filing Date: June 26, 2003		Group: 2815		
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Examiner	Document Number	Date	Name	Class	Subclass	Filing	
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	07-321339	12/08/1995	Japan		T	Abstract	
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	10-056184	02/24/1998	Japan			Abstract	
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Examiner	-		Date Considered			•	